



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RCE/2814
#34 RCE
7/31/03
AMW

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: Shrinivas H. Rao

Filed: October 7, 1997

Docket No.: 039514

For: HIGH ENERGY SUPPLY APPARATUS,
METHOD OF FORMING CRYSTALLINE FILM
AND METHOD OF MANUFACTURING THIN
FILM ELECTRONIC DEVICE

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination and entry and consideration of the June 4, 2003 Amendment After Final Rejection submission. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 143745 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,


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JAO:RJK/mdw

Date: July 1, 2003

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
necessary for entry;
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